



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

NAGAHAMA et al

Atty. Ref.: 925-179

Serial No. 09/500.288

Group: 2814

Filed: February 8, 2000

Examiner: Louie

For: NITRIDE SEMICONDUCTOR DEVICE AND
MANUFACTURING METHOD

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March 28, 2002

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

INFORMATION DISCLOSURE STATEMENT

Attention is invited to the attached copy of an International Search Report published with the counterpart European patent application on March 6, 2002 with respect to this disclosure and a copy of each document cited in it (excluding JP 9-180998 & DE 019648955 already of record) together with a completed Form PTO-1449.

Official citation and consideration of all the attached documents is requested. Please return to the undersigned a copy of the attached PTO-1449 with the examiner's initials in the left column [MPEP §609] with the next communication.

Respectfully submitted,

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